



PATENT

9/A
8/6/03

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Shi, et al.

Title: SYSTEM AND SOFTWARE FOR DATA COLLECTION AND
PROCESS CONTROL IN SEMICONDUCTOR MANUFACTURING
AND METHOD THEREOF

App. No.: 09/905,220 Filed: July 12, 2001

Examiner: Alexander J. Kosowski Group Art Unit: 2125

Atty. Dkt. No.: 1458.TT4869

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

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JUL 31 2003

Technology Center 2100

AMENDMENT/RESPONSE

Dear Sir:

In response to the Office Action mailed April 14, 2003 regarding the above captioned patent application, the Applicant(s) hereby respectfully submit the following amendment and response.

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents on 7-23-03.

Katrina Prati
Typed or Printed Name

Katrina Prati
Signature